

OPENING PORTION 303 / CRYSTALLINE SILICON FILM / MASK 302 / OPENING PORTION 303

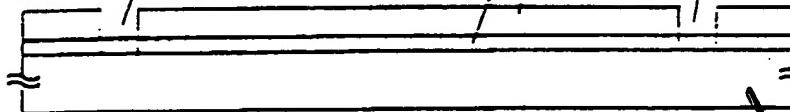


Fig. 3A

ADDING STEP OF PHOSPHORUS

301

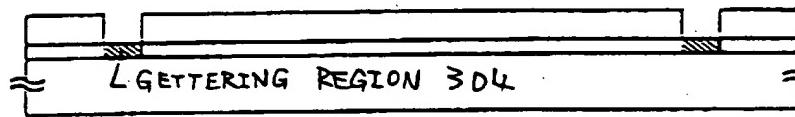


Fig. 3B

GETTERING STEP

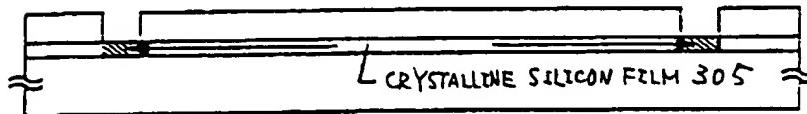


Fig. 3C

HEAT TREATMENT STEP IN REDUCING ATMOSPHERE



Fig. 3D

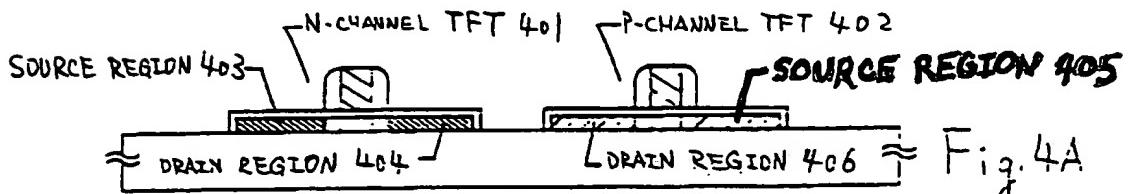


Fig. 4A

GETTERING STEP

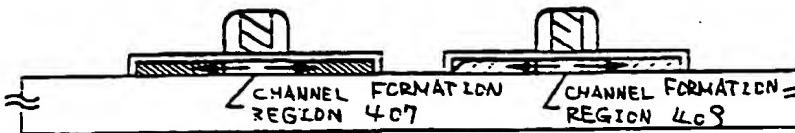


Fig. 4B